TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))

Docket No. OKI.227

In Re Application Of: Norio HIRASHITA

Serial No.

Filing Date

Examiner

Group Art Unit

NEW

APRIL 5, 2001

TO BE ASSIGNED

TO BE ASSIGNED

Title: A STRUCTURE OF A FIELD EFFECT TRANSISTOR HAVING A METALLIC SILICIDE AND MANUFACTURING METHOD THEREOF

Address to:
Assistant Commissioner for Patents
Washington, D.C. 20231



37 CFR 1.97(b)

1. The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application; within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or before the mailing date of a first Office Action on the merits, whichever event occurs last.

37 CFR 1.97(c)

- 2. The Information Disclosure Statement submitted herewith is being filed after three months of the filing of a national application, or the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or after the mailing date of a first Office Action on the merits, whichever occurred last but before the mailing date of either:
 - 1. a Final Action under 37 CFR 1.113, or
 - 2. a Notice of Allowance under 37 CFR 1.311,

whichever occurs first.

Also submitted herewith is:

a certification as specified in 37 CFR 1.97(e);

OR

the fee set forth in 37 CFR 1.17(p) for submission of an Information Disclosure Statement under 37 CFR 1.97(c).

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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

Docket No. OKI.227

(Under 37 CFR 1.97(b) or 1.97(c)) In Re Application Of: Norio HIRASHITA Serial No. Filing Date Examiner Group Art Unit NEW **APRIL 5, 2001** TO BE ASSIGNED TO BE ASSIGNED Title: A STRUCTURE OF A FIELD EFFECT TRANSISTOR HAVING A METALLIC SILICIDE AND MANUFACTURING METHOD THEREOF Payment of Fee (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p)) □ A check in the amount of is attached. ☐ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. as described below. A duplicate copy of this sheet is enclosed. Charge the amount of Credit any overpayment. Charge any additional fee required. Certificate of Transmission by Facsimile* Certificate of Mailing by First Class Mail I certify that this document and fee is being deposited certify that this document and authorization to charge with the U.S. Postal Service as deposit account is being facsimile transmitted to the United first class mail under 37 C.F.R. 1.8 and is addressed to the States Patent and Trademark Office (Fax. No. Assistant Commissioner for Patents, Washington, D.C.) on (Date) 20231. Signature Signature of Person Mailing Correspondence Typed or Printed Name of Person Signing Certificate Typed or Printed Name of Person Mailing Correspondence *This certificate may only be used if paying by deposit account. Dated: APRIL 5, 2001 Signature ADAM C. VOLENTINE **REG. NO. 33289** JONES VOLENTINE, LLC 12200 SUNRISE VALLEY DRIVE, SUITE 150 **RESTON, VA 20191** TEL. NO. (703) 715-0870 CC:

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

not considered. Include copy of this form with next communication to applicant.

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Docket Number (Option	Application Number NEW	
OK1.227		
Applicant(s) Norio HIRASHITA et al.		
Filing Date	Group Art Unit	
APRIL 5, 2001	TO BE ASSIGNED	

- *EXAMINER		OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)
INITIAL		Deep sub-0.1 um MOSFET's with Very Thin SOL Layer for Ultra-Low Power Applicants, Information and Communication Engineers C-II Vol. J81-C-II No. 3, pp. 313-319, موروده الإعلام الإعل
•	A	Eligilicers C-11 vol. 301-C-11 vo. 3, pp. 313-319, pugust 1998.
		Optimization of Series Resistance in Sub-0.2 um SOI MOSFET's, IEEE Electron Device letters, VOL. 15, No. 9, September 1994, p. 363-365.
	В	·•
		Optimization of series resistance in Sub-0.2 um SOI MOSFET's, 1993 IEEE, pp. IEDM93-723-726-IEDM 93.
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EXAMINER		DATE CONSIDERED

P09B/REV04

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and